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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi INOUE et al.

Group Art Unit: 2812

Application No.: 10/748,206

Examiner: R. BOOTH

Filed: December 31, 2003

Docket No.: 040852.98

For: MANUFACTURING METHOD OF ACTIVE MATRIX SUBSTRATE , ACTIVE MATRIX SUBSTRATE AND LIQUID CRYSTAL DISPLAY DEVICE

SUPPLEMENT TO INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

As a supplement to the Information Disclosure Statement filed on April 30, 2007, Applicants provide the attached English-language translation of JP-A-04-178633 for the Examiner's convenience, as a separate statement of relevance regarding the reference.

Respectfully submitted,



James A. Oliff

Registration No. 27,075

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Attachment:  
English-Language Translation of JP-A-04-178633

JAO:JEG/hms

Date: May 16, 2007

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